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ment	of Commerce,	Patent and	Trademark Office		Seria	al No.: 10/	751,160		
					Filing Date: 12/31/03				
INFORMATION DISCLOSURE STATEMENT BY APPLICANT							Inventor: Vlad J. Novotny		
PTIC	CAL SWITCHES W	ITH UNIAXIA	L MIRRORS"		Group	Art Unit:	Unknown		
		·			Exami	ner Name: U	Jnknown		
					Attor	ney Docket	No.: AO-008		
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TABLE						Filing Date: 12/31/03				
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						Filing Date: 12/31/03				
INFORMATION DISCLOSURE STATEMENT BY APPLICANT					Inver	tor: Vlad	J. Novotny			
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						Exami	ner Name:	Unknown		
						Attor	ney Docket	No.: AO-008		
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Sheet 1

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Complete if Known					
Application Number	10/751,160				
Filing Date	12/31/2003				
First Named Inventor	Vlad Novotny				
Art Unit	2874				
Examiner Name	Unknown				
Attorney Docket Number	AO-008				

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Cite No.	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant
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